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## **BIB DATA SHEET**

## CONFIRMATION NO. 2990

This application is a 371 of PCT/JP04/05389 04/15/2004  **FOREIGN APPLICATIONS  **JAPAN 2003-279695 07/25/2003  **IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/18/2006  Foreign Priority claimed   ✓ Yes □ No STATE OR SHEETS TOTAL INDEPENDENT	CONFIRMATION NO. 2990										
APPLICANTS Yulchiro Shindo, Ibaraki, JAPAN;  "CONTINUING DATA "			DATE `´			GR			NO.		
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This application is a 371 of PCT/JP04/05389 04/15/2004  ** FOREIGN APPLICATIONS*** JAPAN 2003-279895 07/25/2003  ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/18/2006  Foreign Priority olaimed											
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Total   Tota	** FOREIGN APPLICATIONS ************************************										
SS USC 119(8-d) conditions met	** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/18/2006										
Acknowledged Examinar's Signature Indicate JAPAN 0 20 2  ADDRESS  HOWSON AND HOWSON SUITE 210 501 OFFICE CENTER DRIVE FT WASHINGTON, PA 19034 UNITED STATES  TITLE Highly pure hafnium material, target thin film comprising the same and method for producing highly pure hafnium  FILING FEE RECEIVED 900  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:    All Fees     1.116 Fees (Filling)     1.117 Fees (Processing Ext. of time)     1.118 Fees (Issue)     Other	D Met after										
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Highly pure hafnium material, target thin film comprising the same and method for producing highly pure hafnium  FILING FEE  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:    Call Fees	HOWSON AND HOWSON SUITE 210 501 OFFICE CENTER DRIVE FT WASHINGTON, PA 19034										
FILING FEE RECEIVED 900 FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:    1.16 Fees (Filing)   1.17 Fees (Processing Ext. of time)   1.18 Fees (Issue)   0 Other	Highly pure hafnium material, target thin film comprising the same and method for producing highly pure										
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